

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)	
)	
Franck Delahaye)	
)	Examiner: Maki Angadi
)	
Application Number:)	
10/599,208)	Art Unit: 1792
)	
Filed: September 22, 2006)	
)	
For: PROCESS FOR THE WET CHEMICAL)	
TREATMENT OF ONE SIDE OF)	
SILICON WAFERS)	
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Response to Office Action

Applicant is responding to the Office Action mailed July 13, 2010, which provides a three month shortened statutory period for reply. This Response is filed within six months of the mailing date and is provided together with a Request for an Extension of Time to file a Reply.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.